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Bib Data Sheet

CONFIRMATION NO. 7953

SERIAL NUMBER 10/625,452	FILING DATE 07/23/2003  RULE	CLASS 438	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. 5649-1144
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APPLICANTS

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\*\* CONTINUING DATA \*\*\*\*\* NONE *W*

\*\* FOREIGN APPLICATIONS \*\*\*\*\* *YR* *W*

REPUBLIC OF KOREA 10-2002-0066087 10/29/2002  
 REPUBLIC OF KOREA 10-2002-0050120 08/23/2002

IF REQUIRED, FOREIGN FILING LICENSE GRANTED  
 \*\* 03/16/2004

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged Examiner's Signature <i>[Signature]</i> Initials <i>LV</i>	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 11	TOTAL CLAIMS 21	INDEPENDENT CLAIMS 2
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 20792  
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TITLE  
 Methods of forming semiconductor devices using an etch stop layer

☐ All Fees